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ATMI, INC.
7 Commerce Drive
Danbury, CT 06810

In Re Application of
XU ET AL.

Application No. 10/632,009

Filed: July 31, 2003

Title: SUPERCRITICAL FLUID-ASSISTED DEPOSITION OF
MATERIALS ON SEMICONDUCTOR SUBSTRATES

NOTICE OF WITHDRAWAL
FROM ISSUE

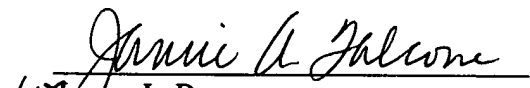
The purpose of this communication is to inform you that the above-identified application is being withdrawn from issue.

The application is being withdrawn to permit reopening of prosecution. The examiner will communicate the reasons to you.

If the issue fee has been submitted, the applicant may request a refund, or may request that the fee be credited to a deposit account. However, the applicant may wait until the application is either again found allowable or held abandoned. If the application is allowed, upon receipt of a new Notice of Allowance and Issue Fee Due, applicant may request that the previously submitted issue fee be applied toward payment of the issue fee in the amount identified on the new Notice of Allowance and Issue Fee Due. If the application is abandoned, applicant may request either a refund or a credit to a specified Deposit Account.

Telephone inquiries should be directed to David Nelms, Supervisory Patent Examiner at (571) 272-1787.

The application is being forwarded to the examiner for prompt appropriate action.


for James L. Dwyer
Director, Technology Center 2800
Communications